

**Notice of References Cited**

Application/Control No.

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Applicant(s)/Patent Under

Reexamination

KIM ET AL.

Examiner

LUCY P. CHIEN

Art Unit

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*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-2002/0033918	03-2002	Shigeno et al.	349/114
*	B US-6,922,219	07-2005	Jin et al.	349/113
C	US-			
D	US-			
E	US-			
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J	US-			
K	US-			
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M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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